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My residence, post office address and citizenship are as stated below next
 y name.

I hereby state that I have reviewed and understand the contents of the re-identified specification, including the claims.

PRIOR FOREIGN APPLICATIONS:

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true and further that these statements were made with the knowledge that willful statements and the like so made are punishable by fine or imprisonment, and that, under Section 1001 of Title 18 of the United States Code and that such a false statement may jeopardize the validity of the application or any patent issued therefrom.

Full name of sole inventor:

Yoshiki Hishiro

Inventor's Signature:

Y. Hishiro

Date:

Feb. 21, 2002

Residence:

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Citizenship:

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. Filed Herewith
Filing Date Filed Herewith
Inventor Yoshiki Hishiro
Assignee Micron Technology, Inc.
Group Art Unit Unknown
Examiner Unknown
Attorney's Docket No. MI22-1873
Title: Semiconductor Constructions; and Methods of Forming Semiconductor
Constructions

**POWER OF ATTORNEY BY ASSIGNEE AND
CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(b)**

To: Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

MICRON TECHNOLOGY, INC., the Assignee of the entire right, title and interest in the above-identified patent application by assignment attached hereto, hereby appoints the attorneys and agents of the firm of WELLS ST. JOHN P.S., listed as follows:

David P. Roberts	Reg. No. 23,032
Randy A. Gregory	Reg. No. 30,386
Mark S. Matkin	Reg. No. 32,268
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James E. Lake	Reg. No. 44,854
Bernard Berman	Reg. No. 37,279
Jennifer J. Taylor	Reg. No. 48,711

and also attorneys Michael L. Lynch (Reg. No. 30,871) and Charles B. Brantley II (Reg. No. 38,086) of Micron Technology, Inc., as its attorneys with full power of substitution to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

The Assignee certifies that the above-identified Assignment has been reviewed and to the best of Assignee's knowledge and belief, title is in the Assignee, and a copy of the Assignment is submitted herewith.

Please direct all correspondence regarding this application to:

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MICRON TECHNOLOGY, INC.

Dated: 2/28/92

By: Roderic W. Lewis

Name: Roderic W. Lewis
Title: Vice-President, Legal, General Counsel
and Corporate Secretary

Attachment: Copy of Assignment